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Notice of Allowability	Application No.	plication No. Applicant(s)	
	10/604,110	10/604,110 LU ET AL.	
	Examiner	Art Unit	
	Jack I. Berman	2881	, , , , , , , , , , , , , , , , , , ,
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	(OR REMAINS) CLOSED i ) or other appropriate comm IGHTS. This application is	n this application. If not include unication will be mailed in due	ded e course. <b>THIS</b>
1. This communication is responsive to			
2. The allowed claim(s) is/are <u>1-20</u> .			
3. $\boxtimes$ The drawings filed on <u>6/26/03</u> are accepted by the Examir	ner.		
4. ☐ Acknowledgment is made of a claim for foreign priority u a) ☐ All b) ☐ Some* c) ☐ None of the:  1. ☐ Certified copies of the priority documents hav 2. ☐ Certified copies of the priority documents hav 3. ☐ Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)).  * Certified copies not received:  Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDON! THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.  5. ☐ A SUBSTITUTE OATH OR DECLARATION must be subn INFORMAL PATENT APPLICATION (PTO-152) which giv 6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") mu (a) ☐ including changes required by the Notice of Draftsper	e been received. e been received in Application cuments have been received of this communication to file MENT of this application.  Initted. Note the attached EX res reason(s) why the oath of the submitted.	on No  ed in this national stage applicate a reply complying with the research AMINER'S AMENDMENT or or declaration is deficient.	equirements
1) hereto or 2) to Paper No./Mail Date  (b) nicluding changes required by the attached Examiner  Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	's Amendment / Comment on 1.84(c)) should be written on 1	or in the Office action of the drawings in the front (not the	ne back) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT			Note the
<ul> <li>Attachment(s)</li> <li>1. ☑ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 6/26/03, 7/31/03)</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material</li> </ul>	6. ☐ Interview S Paper No 08), 7. ☐ Examiner's	Informal Patent Application (Page 1975).  Summary (PTO-413),  Mail Date  Summary Examiner Art Unit: 2881	lowance

The following is an examiner's statement of reasons for allowance: While Nasser-Ghodsi et al. discloses a metrology process using a scanning electron microscope wherein a gas comprising a fluorine bearing compound such as CF<sub>4</sub> (see line 19 in column 5) is introduced during the irradiation of an electron beam onto a specimen in order to increase image contrast of a buried feature by etching and removing material above this feature (see lines 48-58 in column 1), the patent teaches at lines 29-42 in column 1 that this technique of introducing a reactive gas is intended to replace milling of the specimen because such milling tends to cause the contamination referred to in the "Background of Invention" section of the instant application. It would therefore go against the teachings of Nasser-Ghodsi et al. to use the reactive gas technique in addition to milling rather than instead of milling. None of the available prior art teaches to use a fluorine bearing gas to increase the contrast between an oxide layer and a nitride layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jack I. Berman whose telephone number is (571) 272-2468. The examiner can normally be reached on M-F (8:30-6:00) with every second Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (571) 272-2477. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jack I. Berman Primary Examiner Art Unit 2881

jb 6/27/04